

S/N 09/652,713

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Trung T. Doan Examiner: Sylvia MacArthur
Serial No.: 09/652,713 Group Art Unit: 1763
Filed: August 31, 2000 Docket: 303.928US5
Title: CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER
PROCESSING

**NOTICE OF APPEAL FROM THE DECISION OF THE EXAMINER
TO THE BOARD OF PATENT APPEALS AND INTERFERENCES**

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In compliance with 37 C.F.R. § 41.31(a)(1), Applicant hereby appeals to the Board of Patent Appeals and Interferences from the decision dated January 19, 2007, of the Examiner rejecting claims 36-45 of the above-identified patent application.

No extension of time is necessary to respond to the Examiner's rejection.

Please charge the amount of \$500.00 in payment of the Notice of Appeal fee under 37 C.F.R. § 41.20(b)(1), as well as any additional required fees, to Deposit Account No. 19-0743.

Respectfully submitted,

TRUNG T. DOAN

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I hereby certify that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 19 day of April 2007.

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Signature